INTERNATIONAL GEMOLOGICAL INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

September 26, 2026

IGI Report Number	LG841658750
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	HEXAGONAL MODIFIED STEP CUT
Measurements	13.61 X 7.82 X 4.73 MM

GRADING RESULTS

Carat Weight	3.74 CARATS
Color Grade	E
Clarity Grade	VVS 2

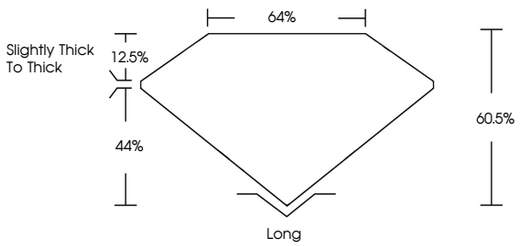
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	LG841658750

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG841658750
Report verification at igi.org

PROPORTIONS





Sample Image Used

COLOR

D	E	F	G	H	I	J	Faint	Very Light	Light

CLARITY

FL	IF	VVS 1 - 2	VS 1 - 2	SI 1 - 2	I 1 - 3
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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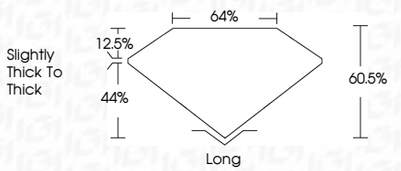
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www.igi.org

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HEXAGONAL MODIFIED STEP CUT
13.61 X 7.82 X 4.73 MM
Carat Weight 3.74 CARATS
Color Grade E
Clarity Grade VVS 2
Depth 60.5%
Table 64%
Girdle Slightly Thick To Thick
Culet Long
Polish EXCELLENT
Symmetry EXCELLENT
Fluorescence NONE
Inscription(s) LG841658750
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Type IIa